PATENT

Docket No.: 43889-951

in the united States patent and trademark office

In re Application of

Koji ERIGUCHI, et al.

Serial No.: 09/610,640

Group Art Unit: 1763

Filed: July 05, 2000

Examiner: EVERHART, Caridad

For:

APPARATUS AND METHOD FOR OPTICAL EVALUATION, APPARATUS AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE, METHOD OF CONTROLLING APPARATUS FOR MANUFACTURING SEMICONDUCTOR

DEVICE, AND SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

TREIVED

Commissioner for Patents Washington, DC 20231

1116 0.5 2004

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

In accordance with 37 CFR 1.17(p), please charge the fee of \$180.00 to Deposit Account No. 500417.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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INFORMATION DISCLOSURE SE RIAL NO. ATTY. DOCKET NO. 09,610,640 CITATION IN ANT E 43889-951 APPLICANT Koji ERIGUCHI, et al. (PTO-1449) **FILING DATE GROUP** July 05, 2000 1763 U.S. PATENT DOCUMENTS **EXAMINER'S** FILING DATE PATENT NO. **INITIALS** DATE NAME **CLASS SUBCLASS** 4,547,074 10/15/85 Hinoda et al. 356 405 5/7/82 5,020,910 6/4/91 Dunn et al. 356 328 3/5/90 5,877,860 3/2/99 Borden 356 376 5/13/96 6,128,084 10/3/00 Nanbu et al. 356 369 6/10/98 6,141,103 10/31/00 Pinaton et al. 356 369 3/17/99 6,175,416 B1 1/16/01 Maris et al. 356 381 8/24/99 5,260,772 11/9/93 Pollak et al. 356 417 7/20/89 5,748,318 5/5/98 Maris et al. 356 381 8/6/96 FOREIGN PATENT DOCUMENTS **EXAMINER'S** Translation INITIALS PATENT NO. DATE COUNTRY CLASS SUBCLASS 63222473 9/16/88 JPO 438 80 X 62119422 5/30/87 JPO 356 43 X 0768512 A2 4/16/97 **EPO** X 6035578 2/23/85 JPO 356 52 X OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) RECEIVED AUG n 5 2004 **EXAMINER** TECH CENTER 2000) DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.